

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To Be Assigned
Examiner: To Be Assigned

In Re PATENT APPLICATION Of:

Applicants :	Tadashi YAMAGUCHI)	INFORMATION DISCLOSURE STATEMENT
Serial No. :	To Be Assigned)	
Filed :	December 31, 2003)	
For :	SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING SEMICONDUCTOR DEVICE)	
Attorney Ref. :	OKI 396)	

December 31, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b)(1).

Attached are copies of three Japanese patent publications. Any relevance of the Japanese patent publications can be gleaned from the attached English-language Abstracts, and from pages 2 to 4 of the present application, where these documents are discussed. The patent publications are listed on the attached Form PTO-1449. Also listed on the Form PTO-1449 for consideration is one U.S. patent. Any relevance of this U.S. patent is self-evident.

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to the documents submitted. Consideration of the submitted and listed documents is respectfully requested.

Respectfully submitted,



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December 31, 2003
Date

RHB:tz

Fee Enclosed: \$ 810
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fee to our Deposit Account
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FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT		Atty Docket	Application No.				
		OKI 396	To Be Assigned				
		Applicant					
		Tadashi YAMAGUCHI					
Filing Date	Group Unit						
December 31, 2003	To Be Assigned						
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA	6,391,685	05/21/02	Hikita et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Trans-lation
	AK	2002-093942	03/29/02	Japan			Abstract
	AL	2000-243900	09/08/00	Japan			Abstract
	AM	06-005665	01/14/94	Japan			Abstract
	AN						
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
	AQ						
	AP						
	AQ						
	AR						
Examiner				Date Considered			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							